# Quantum and Nonlinear Optical Imaging Robert W. Boyd

The Institute of Optics, University of Rochester

- The promise of quantum imaging (including quantum lithography)
- Imaging upconversion (for astronomy and for THz imaging)
- Nonlinear optical microscopy

# Nonclassical, Two-Photon Interferometry and Lithography with High-Gain Optical Parametric Amplifiers

Robert W. Boyd, Elna M. Nagasako, Sean J. Bentley University of Rochester, USA and Girish S. Agarwal, Physical Research Lab., India

To what extent do unseeded, high-gain optical parametric amplifiers preserve the desirable quantum statistical properties of spontaneous parametric downconversion?

#### **Quantum Lithography and Microscopy**

- Entangled photons can be used to form interference patterns with detail finer than the Rayleigh limit
- Process "in reverse" performs sub-Rayleigh microscopy



Boto et al, Phys. Rev. Lett. 85, 2733, 2000.

#### **QUANTUM LITHOGRAPHY PROPOSAL**



"Replace" parametric down converter (PDC) with optical parametric amplifier (OPA)-essentially the same device, but now pumped harder to generate sufficient energy levels to be recorded by two-photon responsive lithographic plate at  $a_3$ .

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## Use of High-Gain Parametric Amplifier

Is two-photon interference pattern preserved?



two-photon recording medium

• Transfer equations of OPA

where 
$$\hat{a}_1 = U\hat{a}_0 + V\hat{b}_0^{\dagger}, \quad \hat{b}_1 = U\hat{b}_0 + V\hat{a}_0^{\dagger}$$
  
 $U = \cosh G \qquad V = -i\exp(i\varphi)\sinh G$ 

· Field at recording medium

$$\hat{a}_3 = \frac{1}{\sqrt{2}} \left[ (-e^{i\chi} + i)(U\hat{a}_0 + V\hat{b}_0^{\dagger}) + (ie^{i\chi} - 1)(U\hat{b}_0 + V\hat{a}_0^{\dagger}) \right]$$

Two-photon absorption probablility



(Phys. Rev. Lett. 86, 1389, 2001) .

#### **QUANTUM LITHOGRAPHY PROPOSAL**

#### **Experimental Layout**





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#### Hong-Ou-Mandel Interferometer



• Transfer equations of OPA

where 
$$\hat{a}_1 = U\hat{a}_0 + V\hat{b}_0^{\dagger}, \quad \hat{b}_1 = U\hat{b}_0 + V\hat{a}_0^{\dagger}$$
  
 $U = \cosh G \qquad V = -i\exp(i\varphi)\sinh G$ 

• Fields leaving the beamsplitter



## Mach-Zehnder Coincidence-Count Statistics



• Transfer equations of OPA

where 
$$\hat{a}_1 = U\hat{a}_0 + V\hat{b}_0^{\dagger}, \quad \hat{b}_1 = U\hat{b}_0 + V\hat{a}_0^{\dagger}$$
  
 $U = \cosh G \qquad V = -i\exp(i\varphi)\sinh G$ 

• Fields at detectors

$$\hat{a}_{3} = \frac{1}{2} [(1 - e^{i\chi})(U\hat{a}_{0} + V\hat{b}_{0}^{\dagger}) - i(1 + e^{i\chi})(U\hat{b}_{0} + V\hat{a}_{0}^{\dagger})]$$
  
$$\hat{b}_{3} = \frac{1}{2} [-i(1 + e^{i\chi})(U\hat{a}_{0} + V\hat{b}_{0}^{\dagger}) - (1 - e^{i\chi})(U\hat{b}_{0} + V\hat{a}_{0}^{\dagger})]$$

• Joint detection probability

$$\langle \hat{a}_3^{\dagger} \hat{b}_3^{\dagger} \hat{b}_3 \hat{a}_3 \rangle = |V|^2 \left[ \frac{1}{2} (1 + \cos 2\chi) + |V|^2 (\frac{3}{2} + \frac{1}{2} \cos 2\chi) \right]$$



Ou, Zou, Wang, Mandel, Phys. Rev. A 42, 2957, 2000.

Conclusion: Some but not all of the quantum statistical features of the spontaneous parametric down conversion are preserved in the output of an unseeded, high-gain optical parametric amplifier.\*

But why?

\*Nagasako, Bentley, Boyd, and Agarwal, accepted for publication in PRA

# Processes Contributing to the Coincidence Count Rate



(And interference among these processes!)

#### **General Treatment of Nonclassical Interferometers**

Input/Output Relation of Interferometer

$$\begin{pmatrix} \hat{a}_1 \\ \hat{a}_2 \end{pmatrix} = \begin{pmatrix} A & B \\ C & D \end{pmatrix} \begin{pmatrix} \hat{a}_s \\ \hat{a}_i \end{pmatrix}$$

Direct Output A = D = 1 B = C = 0.

Beam Splitter  $A = D = \frac{1}{\sqrt{2}}$   $B = C = \frac{-i}{\sqrt{2}}$ Quantum Litho.  $A = C = \frac{1}{\sqrt{2}} - \frac{i}{\sqrt{2}}e^{i\chi}$   $B = D = -\frac{i}{\sqrt{2}} + \frac{1}{\sqrt{2}}e^{i\chi}$ 

#### **Coincidence Detection Rate**

$$\begin{split} \langle \hat{a}_{1}^{\dagger} \hat{a}_{2}^{\dagger} \hat{a}_{2} \hat{a}_{1} \rangle &= |C|^{2} |A|^{2} \langle \hat{a}_{s}^{\dagger} \hat{a}_{s}^{\dagger} \hat{a}_{s} \hat{a}_{s} \hat{a}_{s} \rangle \\ &+ |D|^{2} |A|^{2} \langle \hat{a}_{s}^{\dagger} \hat{a}_{i}^{\dagger} \hat{a}_{i} \hat{a}_{s} \rangle \\ &+ |C|^{2} |B|^{2} \langle \hat{a}_{i}^{\dagger} \hat{a}_{i}^{\dagger} \hat{a}_{s} \hat{a}_{i} \rangle \\ &+ |D|^{2} |B|^{2} \langle \hat{a}_{i}^{\dagger} \hat{a}_{i}^{\dagger} \hat{a}_{i} \hat{a}_{i} \rangle \\ &+ 2 \operatorname{Re} A^{*} C^{*} DA \langle \hat{a}_{s}^{\dagger} \hat{a}_{s}^{\dagger} \hat{a}_{i} \hat{a}_{s} \rangle \\ &+ 2 \operatorname{Re} A^{*} C^{*} DB \langle \hat{a}_{s}^{\dagger} \hat{a}_{s}^{\dagger} \hat{a}_{i} \hat{a}_{i} \rangle \\ &+ 2 \operatorname{Re} A^{*} D^{*} CB \langle \hat{a}_{s}^{\dagger} \hat{a}_{i}^{\dagger} \hat{a}_{i} \hat{a}_{i} \rangle \\ &+ 2 \operatorname{Re} A^{*} D^{*} CB \langle \hat{a}_{s}^{\dagger} \hat{a}_{i}^{\dagger} \hat{a}_{i} \hat{a}_{i} \rangle \\ &+ 2 \operatorname{Re} A^{*} D^{*} DB \langle \hat{a}_{s}^{\dagger} \hat{a}_{i}^{\dagger} \hat{a}_{i} \hat{a}_{i} \rangle \\ &+ 2 \operatorname{Re} B^{*} C^{*} DB \langle \hat{a}_{i}^{\dagger} \hat{a}_{i}^{\dagger} \hat{a}_{i} \hat{a}_{i} \rangle \end{split}$$

# Interferometer-Dependent Coefficients of the Individual Contributions to the Joint Detection Probability

|  |                                       | OP | А | НОМІ | QL       |   |          |
|--|---------------------------------------|----|---|------|----------|---|----------|
| $\prec$  | C  <sup>2</sup>  A  <sup>2</sup>      | 0  |   | 1/4  | (1+sin   |   | )2       |
| $\times$   | D  <sup>2</sup>  A  <sup>2</sup>      | 1  |   | 1/4  | 1-sin    | 2 |          |
| $\rightarrow$  | C  <sup>2</sup>  B  <sup>2</sup>      | 0  |   | 1/4  | 1-sin    | 2 |          |
|  | D  <sup>2</sup>  B  <sup>2</sup>      | 0  |   | 1/4  | (1-sin   |   | )2       |
| $\not\prec \oplus \not\preccurlyeq$  | 2 Re A*C*DA                           | 0  |   | 0    | 2 cos    |   | (1+sin ) |
| $\not\prec \oplus \not\prec \checkmark$  | 2 Re A*C*CB                           | 0  |   | 0    | 2 cos    |   | (1+sin ) |
| $\not\prec \oplus \checkmark \checkmark$                                       | 2 Re A <sup>*</sup> C <sup>*</sup> DB | 0  |   | 1/2  | 2 cos    | 2 |          |
| $\not\!$ | 2 Re A*D*CB                           | 0  |   | -1/2 | 2 (1-sin |   | 2 )      |
| $\not = \not = \not =$   | 2 Re A <sup>*</sup> D <sup>*</sup> DB | 0  |   | 0    | 2 cos    |   | (1-sin ) |
| $\not\!$ | 2 Re B <sup>*</sup> C <sup>*</sup> DB | 0  |   | 0    | 2 cos    |   | (1-sin ) |

single-input terms = both detected photons arise from a single input arm dual-input terms = detected photons arise from both input arms

# Quantum Expectation Values of the Individual Contributions to the Joint **Detection Probability**

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|  |   | 1 1> | lm m>          | lα <sub>0</sub> α <sub>0</sub> > | OPA                             |
|--|---|------|----------------|----------------------------------|---------------------------------|
| $\prec$  | <as<sup>tas<sup>t</sup>asas&gt;</as<sup>                      | 0    | m(m-1)         | Ια <sub>0</sub> Ι <sup>4</sup>   | 2(m) <sup>2</sup>               |
| $\varkappa$  | <as<sup>†ai<sup>†</sup>aias&gt;</as<sup>                      | 1    | m <sup>2</sup> | lα <sub>0</sub> l <sup>4</sup>   | 2(m) <sup>2</sup> + m           |
| $\times$   | <ai<sup>†as<sup>†</sup>asai&gt;</ai<sup>                      | 1    | m²             | اα <sub>0</sub> Ι <sup>4</sup>   | 2(ħ) <sup>2</sup> + ħ           |
| $\prec$  | <aitaitaiai></aitaitaiai>                                     | 0    | m(m-1)         | Ια <sub>0</sub> Ι <sup>4</sup>   | 2(m) <sup>2</sup>               |
| $\neq \bullet \not \approx$  | <as<sup>†as<sup>†</sup>aias&gt;</as<sup>                      | 0    | 0              | Ια <sub>0</sub> Ι <sup>4</sup>   | 0                               |
| $\not\prec_{\oplus} \not\asymp$  | <a<sub>sta<sub>s</sub>ta<sub>s</sub>a<sub>i</sub>&gt;</a<sub> | 0    | 0              | Ια <sub>0</sub> Ι <sup>4</sup>   | 0                               |
| $\not\prec_{\oplus}\not\prec$  | <as<sup>tas<sup>t</sup>aiai&gt;</as<sup>                      | 0    | 0              | Ια <sub>0</sub> Ι <sup>4</sup>   | 0                               |
| $\times \odot \times$  | <a<sub>staitasai&gt;</a<sub>                                  | 1    | m²             | Ια <sub>0</sub> Ι <sup>4</sup>   | <b>2(m៊</b> ) <sup>2</sup> + m៊ |
| $\not\!$ | <a<sub>staitaiai&gt;</a<sub>                                  | 0    | 0              | Ια <sub>0</sub> Ι <sup>4</sup>   | 0                               |
| $\not\prec \oplus \not\prec$   | <ai<sup>tas<sup>t</sup>aiai&gt;</ai<sup>                      | 0    | 0              | lα <sub>0</sub> l <sup>4</sup>   | 0                               |



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Nature of Decreased Fringe Visibility in a High-Gain Optical Parametric Amplifier





# **Generation of Squeezed Light by use of EIT**

Robert W. Boyd and C. R. Stroud, Jr., University of Rochester

## **Three Approaches**







**Fundamental idea:** EIT eliminates linear absorption so that there is no spontaneous emission background noise.

# Application of Two-Level EIT to Squeezed-Light Generation

• Squeezing by self-phase modulation



Blow, Loudon, and Phoenix, J. Mod. Opt., 40, 2515, 1993

EIT allows phase shifts large enough to produce significant squeezing, and prevents signal-beam absorption which can degrade the squeezing.

## **Honey Comb Pattern Formation**

Robert W. Boyd and C. R. Stroud, Jr., University of Rochester

#### Output from cell with single gaussian beam input



Quantum image?

Input power 150 mWInput beam diameter 0.22 mm  $\lambda = 588.995 \text{ nm}$  Sodium vapor cell  $T = 220^{\circ} C$ 

# Some Related Findings







 spontaneous pattern formation in nematic LC with mirror feedback

R. MacDonald and H.J. Eichler, Opt. Comm. **89** (1992) 289-295.

 simulation of pattern formation in a Kerr slice with mirror feedback

F. Papoff, G. D'Alessandro, G.-L. Oppo, and W.J. Firth, Phys. Rev. A **48** (1993) 634.

 spontaneous pattern formation in sodium vapor with a feedback mirror

R. Herrero, E. Grosse Westhoff, A. Aumann, T. Ackemann, Y. A. Logvin, and W. Lange, Phys. Rev. Lett. **82** (1999) 4627.



 spontaneous pattern formation in a neardegenerate OPO

M. Vaupel, A. Maitre, and C. Fabre, Phys. Rev. Lett. **83** (1999) 5278.



 filementation of an aberrated beam in sodium vapor

J.W. Grantham, H.M. Gibbs, G. Khitrova, J.F. Valley, and Xu Jiajin, Phys Rev. Lett. **66** (1991) 1422.

# Experimental Results



 $N = 3 \times 10^{12} \text{ cm}^{-3}$ , P = 110 mW,  $2w = 180 \mu \text{m}$ 

# Spontaneous Pattern Formation in Sodium Vapor

A sodium vapor may be thought of as a medium composed of two-level atoms. Light whose frequency is near the atomic transition frequency experiences a refractive index n which depends strongly on the intensity I:



Since light refracts in the direction of increasing index, in a medium with negative saturable nonlinearity it refracts toward regions of higher intensity. This causes smooth beams to narrow or self-focus. But it also tends to destabilize a beam as small amplitude fluctuations grow due to local self-focusing. Thus beams with even small amplitude noise can spontaneously split into two or more separate beams.

# Z = 40.3 Z = 0.0t≋ 20 ⊠ Z = 94.9Z = 126.1-20 -40 \_40 -40 <u>-</u>4n

Experimental observation of spontaneous break-up resulting in a striking far-field pattern:





beam entering sodium



#### A simulation of spontaneous break-up into 3 stable beams:



beam leaving sodium



far-field pattern

# **Some Underlying Issues in Nonlinear Optics**

- Self-Assembly/Self-Organization in Nonlinear Systems
- Stability vs. Instability (and Chaos) in Nonlinear Systems

**Chaos in Sodium Vapor** 



PRL 58, 2432 (1987); 61, 1827 (1988); 64 1721 (1990).

Laser Beam Filamentation Spatial growth of wavefront perturbations





Fig. 17.2 Image of small-scale filaments at the exit windows of a  $CS_2$  cell created by self-focusing of a multimode laser beam. [After S. C. Abbi and H. Mahr, *Phys. Rev. Lett.* 26, 604 (1971).]

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# **Experiment in Self Assembly**



#### Joe Davis, MIT

# Nanofabrication

- Materials (artificial materials)
- Devices

(distinction?)

Ultrafast All-Optical Switch Based On Arsenic Triselenide Chalcogenide Glass

• We excite a whispering gallery mode of a chalcogenide glass disk.



- The nonlinear phase shift scales as the square of the finesse F of the resonator. (F  $\approx 10^2$  in our design)
- Goal is 1 pJ switching energy at 1 Tb/sec.



J. E. Heebner and R. W. Boyd, Opt. Lett. 24, 847, 1999. (implementation with Dick Slusher, Lucent)

# **A Real Whispering Gallery**



## St. Paul's Cathedral, London

# NLO of SCISSOR Devices

(Side-Coupled Integrated Spaced Sequence of Resonators)



Displays slow-light, tailored dispersion, and optical solitons. Description by NL Schrodinger eqn. in continuum limit.

• Pulses spread when only dispersion is present



• But form solitons through balance of dispersion and nonlinearity



(J.E. Heebner, Q-Han Park and RWB)



## **Center for Biochemical Optoelectronic Microsystems**

Cornell, Harvard, University of Rochester

#### **Disk Resonator for the Detection of Biological Pathogens**

R. Boyd, J. Heebner

# **Objective:**

Obtain high sensitivity, high specificity detection of pathogens through optical resonance

# **Approach/Features:**

Construct high-finesse whispering-gallery-mode disk resonator.

Presence of pathogen on surface leads to dramatic decrease in finesse.

# Simulation of device operation: (FDTD)



Intensity distribution in absense of absorber.

## **Progress:**

Device design is complete. Beginning fabrication



Intensity distribution in presence of absorber.

## **Nonlinear Optical Loop-De-Loop**



J.E. Heebner and R.W.B.